



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Ewald Karl Michael Guenther, Art Unit : 1732
Zhong Chen and Brian Cotterell Examiner : Leo B. Tentoni
Serial No. : 09/786,832
Filed : June 13, 2001
Title : MECHANICAL PATTERNING OF A DEVICE LAYER

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

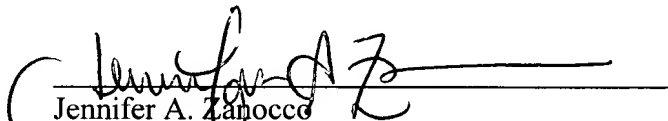
INFORMATION DISCLOSURE STATEMENT

Applicant submits the references listed on the attached form PTO-1449.

This filing is being made with the filing of a Request for Continued Examination. No fee is required.

Respectfully submitted,

Date: 11/10/03



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November 10, 2003
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Carlos A. Brasil
Typed or Printed Name of Person Signing Certificate

Substitute Form PTO-1449

U.S. Department of Commerce
Patent and Trademark OfficeAttorney's Docket No.
12406-014001Application No.
09/786,832**Information Disclosure Statement
by Applicant**

(Use several sheets if necessary)

(37 CFR § 1.98(b))

Applicant

Ewald Karl Michael Guenther, Zhong Chen and
Brian Cotterell

Filing Date

June 13, 2001

Group Art Unit

1732

U.S. Patent Documents

| Examiner Initial | Desig. ID | Document Number | Publication Date | Patentee | Class | Subclass | Filing Date If Appropriate |
|------------------|-----------|-----------------|------------------|-----------------|-------|----------|----------------------------|
| | AA | 4,720,432 | 01/19/1988 | VanSlyke et al. | | | |
| | AB | | | | | | |
| | AC | | | | | | |
| | AD | | | | | | |
| | AE | | | | | | |
| | AF | | | | | | |
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| | AI | | | | | | |
| | AJ | | | | | | |
| | AK | | | | | | |

Foreign Patent Documents or Published Foreign Patent Applications

| Examiner Initial | Desig. ID | Document Number | Publication Date | Country or Patent Office | Class | Subclass | Translation | |
|------------------|-----------|-----------------|------------------|--------------------------|-------|----------|-------------|----|
| | | | | | | | Yes | No |
| | AL | | | | | | | |
| | AM | | | | | | | |
| | AN | | | | | | | |
| | AO | | | | | | | |
| | AP | | | | | | | |

Other Documents (include Author, Title, Date, and Place of Publication)

| Examiner Initial | Desig. ID | Document |
|------------------|-----------|--|
| | AQ | Berggren, M., Dodabalapur, A., Slusher, R.E., Timko, A., and Nalamasu, O., "Organic Solid-State Lasers with Imprinted Gratings on Plastic Substrate", January 1998, Applied Physics Letter 72 (4) pp. 410-411. |
| | AR | |
| | AS | |
| | AT | |

Examiner Signature

Date Considered

EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.